

*Citations for :* **Dielectric Targets** *Ion = Ar*

<b>Pub. Year</b>	<b>Authors, Title, Journal Citation and Comments</b>	<b>Citation Numb</b>
<b>1963</b>	McCargo, M. Davies, J. A. Brown, F. <b>'Range of Xe133 and Ar41 Ions of keV Energies in Tungsten'</b> <i>Can. J. Phys., 41, 1231-44 (1963)</i> <i>Comment : R, dR. 2-200 keV 133Xe, 41Ar -&gt; W, 40 keV 85Kr -&gt; WO3</i>	<b>1963-McCa2</b>
<b>1964</b>	Domeij, B. Brown, F. Davies, J. A. McCargo, M. <b>'Ranges of Heavy Ions in Amorphous Oxides'</b> <i>Can. J. Phys., 42, 1624-34 (1964)</i> <i>Comment : R, dR. 0.5-160 keV 24 Na, 41Ar, 85Kr, 125Xe -&gt; Al2O3, WO3</i>	<b>1964-Dome2</b>
<b>1964</b>	Moritzer, L. Scharmann, A. <b>'Messung der Eindringtiefe von Elektronen und Ionen in Dunnen Aufdampfschichten'</b> <i>Z. Physik, 181, 67-86 (1964)</i> <i>Comment : R. 1-10 keV H, 1-12 keV He, 1-30 keV Ne, Ar -&gt; LiF, NaF, MgF2, CaF2, ZnS.</i>	<b>1964-Morb</b>
<b>1967</b>	Hastings, L. Ryall, P. R. VanWijngaarden, A. <b>'The Energy Loss of Heavy Ions in ZnS: Ag in the keV Range'</b> <i>Can. J. Phys., 45, 2334-42 (1967)</i> <i>Comment : S. (5-100 keV) H, He, N, Ar, Kr -&gt; ZnS:Ag</i>	<b>1967-Hast</b>
<b>1967</b>	Hastings, L. VanWijngarden, A. <b>'The Energy Loss, the Detioration Depth and the Light Output for Heavy Ions in Zno:Zn'</b> <i>Can. J. Phys., 45, 4039-51 (1967)</i> <i>Comment : S Rel. To P. 10-100 keV He, N, Ar, Kr -&gt; ZnO:Zn</i>	<b>1967-Hast2</b>
<b>1970</b>	Bach, H. <b>'Zur Bestimmung der Reichweiten von Beschleunigten Ionen in Dunner Oxschichten'</b> <i>Z. Angew. Phys., 28, 239-44 (1970)</i> <i>Comment : R. 4.2-5.6 keV Ar -&gt; SiO2, TiO2</i>	<b>1970-Bach</b>
<b>1970</b>	Schalch, D. Scharmann, A. <b>'Eindringtiefen von Ionen in CaF2-Und Rb-Aufdampfschichten'</b> <i>Z. Angew. Phys, 29, 111-13 (1970)</i> <i>Comment : R. 10-80 keV H, He, Ne, Ar, Kr, Xe -&gt; CaF2, Rb</i>	<b>1970-Scha</b>
<b>1974</b>	Bach, H. <b>'Partial Disintegration and Charge of Concentration Profiles at Ion Bombarded Na Silicate Glass Surfaces'</b> <i>Rad. Effects, 22, 73-78 (1974)</i> <i>Comment : R. 5.6 keV Ar -&gt; Na Silicate Glass</i>	<b>1974-Bach</b>
<b>1974</b>	Bach, H. Kitzmann, I. Schroder, H. <b>'Sputtering Yields and Specific Energy Losses of Ar+ Ions with Energies from 5 to 30 keV at SiO2'</b> <i>Rad. Effects, 21, 31-36 (1974)</i> <i>Comment : S. 5-30 keV Ar -&gt; SiO2</i>	<b>1974-Bach2</b>

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<b>1974</b>	Blok, H. Kiely, F. M. Pate, B. D. Hanappe, F. Pelier, J. <b>'Further Measurement of the Track Length of Heavy Ions in Mica'</b> <i>Nucl. Inst. Methods, 119, 307-12 (1974)</i> <i>Comment : R. (2.7-160 MeV) Al, Ar, Ca, Cr, Ni, Se, Kr, Ag -&gt; Mica</i>	<b>1974-Blok</b>
<b>1974</b>	EerNisse, E. P. <b>'Compaction of Ion Implanted Fused Silica'</b> <i>J. Appl. Phys., 45, 167-174 (1974)</i> <i>Comment : R. H, He, O, Ne, Ar (150-300 keV) -&gt; SiO<sub>2</sub> One of the earliest SiO<sub>2</sub> compaction studies.</i>	<b>1974-EerN</b>
<b>1976</b>	Pringle, J. P. S. <b>'A Comparison of Sectioning Methods used to Measure Concentration Profiles in Anodic Oxides'</b> <i>Can. J. Phys., 54, 56-65 (1976)</i> <i>Comment : R. dR. (10-160 keV) Na, Ar, K, Kr, Xe -&gt; Al<sub>2</sub>O<sub>3</sub>, Ta<sub>2</sub>O<sub>5</sub>, WO<sub>3</sub>, Ta<sub>2</sub>O<sub>5</sub></i>	<b>1976-Prin</b>
<b>1978</b>	Stephens, K. G. Wilson, I. H. <b>'Properties and Applications of Ion-Implanted Films'</b> <i>Thin Solid Films, 50, 325-347 (1978)</i> <i>Comment : R. 30 keV O -&gt; Ta<sub>2</sub>O<sub>5</sub>, 60-80 keV Ar -&gt; Ta</i>	<b>1978-Step</b>
<b>1979</b>	Aframian, A. <b>'Dependence of the Stopping Power of Charged Particles in the Physical State of Organic Dielectric Compounds'</b> <i>Appl. Phys., 19, 353-358 (1979)</i> <i>Comment : S. He, Ar, Kr (1-40 MeV/amu) -&gt; Cell-Nitrate, Polyethylene, Polystyrene, Mylar, Melinex</i>	<b>1979-Afra</b>
<b>1981</b>	Salomon, M. H. Ahlen, S. P. Tarle, G. Creggin, K. C. <b>'Measurement of Higher Order Corrections to Stopping Power for Relativistic Ne, Ar and Fe Beams'</b> <i>Phys. Rev. A, 23, 1, 73-76 (1981)</i> <i>Comment : R. Ne, Ar, Fe (600 MeV/amu) -&gt; Al, Ar, Pb, Air, Kapton, CO<sub>2</sub>, Lexan</i>	<b>1981-Sala</b>
<b>1986</b>	Bimbot, R. Gauvin, H. Orliange, I. <b>'Stopping Powers of Solids for Ar and Ca Ions at Intermediate Energies (20-80 MeV/amu)'</b> <i>Nucl. Inst. Methods, B17, 1-10 (1986)</i> <i>Comment : S. Ar, Ca (20-80 MeV/amu) -&gt; Be, C, Al, Si, Ti, Ni, Cu, Ag, Ta, Au, Mylar</i>	<b>1986-Bimb</b>
<b>1988</b>	Balanzat, E. Jousset, J. C. Toulemonde, M. <b>'Latent Tracks Induced by Heavy Ions in the GeV Energy Range: Results at GANIL'</b> <i>Nucl. Inst. Methods, B32, 368-376 (1988)</i> <i>Comment : R. O, Ar, Kr, Mo, Xe, U (4-85 MeV/amu) -&gt; Polymers, Insulators, Superconductors: Track Analysis</i>	<b>1988-Bala</b>

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<b>1993</b>	Bogdanov, S. D. Zhurkin, E. E. Kosmach, V. F. Hassan, D. <b>'Effect of Z*3 Correction in Ionization Energy Losses on the Ranges of Heavy Ions'</b> <i>Pis'Ma Zh. Eksp. Teor. Fiz. (Russia), 58, 711-714 (1993) [Eng. Trans. JETP Letters, (1993)]</i> <i>Comment : R. Ne, Ar, Fe, Au, U (0.3-1.2 GeV/amu) -&gt; Emulsion</i>	<b>1993-Bogd</b>
<b>1995</b>	Bogdanov, S. S. Dudkin, V. E. Hassan, J. <b>'Ranges of 0.2-1.0 GeV/amu Heavy Ions in Nuchor'</b> <i>Rad. Meas. (UK), 25, 111-114 (1995)</i> <i>Comment : R. Ne, Ar, Fe, Au, U (0.2-1.0 GeV/amu) -&gt; BR-2 (Nuchor) photoemulsion</i>	<b>1995-Bogd</b>
<b>2001</b>	Diwan, P. K. Kumar, S. Singh, G. Singh, L. <b>'Energy Loss of Heavy Ions in Gases: A Comparative Study'</b> <i>Rad. Meas., 33, 193-202 (2001)</i> <i>Comment : S. Ne, S,Cl,Ar,Cu,Kr (1 - 80 MeV/u) -&gt; H,He, N,Ar,Ne,Xe,CH4,C4H10,CO2,CF4</i>	<b>2001-Diwa2</b>

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